

Application/6	cation/Control No. Applicant(s)/Patent under Reexamination		
10/530,267		RADULESCU ET AL.	
Examiner		Art Unit	
Raymond PI	nan	2111	

SEARCHED				
Class	Subclass	Date	Examiner	
710	306-317, 104-110, 56-61	8/6/2007	RP	
709	201-203	8/6/2007	RP	
709	310-317	8/6/2007	RP	

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
		<u>.</u>			
	<u> </u>				

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST search	8/9/2007	RP		
,				
	- N			